Comparison of optical spectra recorded during DPF-I000U plasma experiments with gas-puffing

Abstract. The results are presented of the optical spectra measurements for free plasma streams generated with the use of the modified DPF-1000U machine. This facility was recently equipped with a gas injection system (the so-called gas-puff) placed on the symmetry axis behind the central opening in the inner electrode. The DPF-1000U experimental chamber was filled up with pure deuterium at the initial pressure of 1.6 or 2.4 mbar. Additionally, when the use was made of the gas-puff system about 1 cm$^3$ of pure deuterium was injected at the pressure of 2 bars. The gas injection was initiated 1.5 or 2 ms before the triggering of the main discharge. The investigated plasma discharges were powered from a condenser bank charged initially to 23 kV (corresponding to the energy of 352 kJ), and the maximum discharge current amounted to about 1.8 MA. In order to investigate properties of a dense plasma column formed during DPF-1000U discharges the use was made of the optical emission spectroscopy. The optical spectra were recorded along the line of sight perpendicular to the vacuum chamber, using a Mechelle$^{	ext{TM}}$900 spectrometer. The recent analysis of all the recorded spectra made it possible to compare the temporal changes in the electron density of a freely propagating plasma stream for discharges without and with the gas-puffing. Using this data an appropriate mode of operation of the DPF-1000U facility could be determined.

Key words: electron density • gas-puff • optical spectrum • plasma focus • plasma stream

Introduction

Investigation of the optical spectra emitted from plasma streams is of primary importance for determination of the composition and the dynamics of such plasma objects. The optical emission spectroscopy (OES) has already been used for the investigation of intense pulsed plasma-ion streams generated with the use of the 1 MJ plasma focus facility [1–4], but recent modifications of this machine, and particularly the installation of the gas-puffing, have made it necessary to perform anew the detailed spectroscopic measurements. In this note the most important results are presented of experimental studies performed with the use of the modified DPF-1000U facility without and with the gas-puffing.

Experimental setup

The DPF-1000U facility is equipped with two 460 mm long coaxial electrodes. The inner electrode has the form of a thick copper tube 230 mm in diameter, and its front plate has an axial hole 50 mm
in diameter, behind which the fast-acting gas valve outlet nozzle is located. The outer electrode is 400 mm in diameter and consists of twelve stainless-steel tubes 80 mm in diameter, which are symmetrically distributed around the axis [5].

During the reported experiments the DPF-1000U chamber was filled up with pure deuterium under a pressure of $p_o = 1.6$ or 2.4 mbar. Some discharges were performed without gas-puffing, but in the cases when the gas-puffing was applied about 1 cm$^2$ of pure deuterium under a pressure of 2 bars was injected along the axis 1.5 or 2 ms before the discharge was triggered. It should be noted, however, that the triggering of the gas valve at the chosen instant did not cause an instantaneous injection of the whole gas amount (ca. $10^{20}$ deuterium atoms). The gas valve remained open for at least several milliseconds, and the inflowing gas formed a stream along the z-axis practically during the whole discharge lasting several microseconds [1]. For this reason the injected gas has not been ‘dissolved’ in the gas filling the whole discharge chamber, but it formed a gas target for the collapsing current sheath. Therefore, an influence of the gas-puffing was noticeable, e.g., on laser interferometric images as well as on X-ray and neutron emission characteristics [6].

It should be added that during the reported experiments the DPF-1000U discharges were powered from a condenser bank charged to $U_o = 23$ kV, which corresponded to $W_o = 352$ kJ, and the maximum discharge current amounted to 1.8 MA in about 5 µs [1].

As mentioned above, in order to investigate the generated plasma-ion streams the optical emission spectra were registered in the visible range. Measurements were performed by means of a Mechelle®900 spectrometer coupled through an optical fibre cable with a collimator situated behind an optical window. Those optical spectra were recorded along a line of sight almost perpendicular to the z-axis, at a distance of 9 cm from the electrode ends, where the target was located during the previous experiments [4, 5]. The experimental arrangement for this experiment is presented in Fig. 1.

### Experimental results

In order to compare the optical emission spectra for DPF-1000U discharges carried out under different experimental conditions, the optical measurements were initially performed without any gas-puffing. It should be noted that in comparison with the optical spectra observed in the previous PF-1000 experiments [2–4] the spectra recorded recently in the DPF-1000U facility without the gas-puffing showed negligible differences in lines shapes and intensities. Some examples of the optical spectra recorded at different instants before and after the discharge current peculiarity (the so-called current dip) are shown in Fig. 2.

For the DPF-1000U discharges performed with the gas-puffing some important differences were observed. Examples of the optical spectra recorded at different initial pressures in the experimental chamber are presented in Figs. 3 and 4.

One can easily see that in the considered cases there appeared many impurity lines, and their intensities increased considerably in later phases of the discharge. In particular, spectral lines corresponding to Cu, Fe and C elements were recorded. For a comparison, some changes in the profile of the $D_\alpha$...
Comparison of optical spectra recorded during DPF-1000U plasma experiments with gas-puffing

line, as observed in the spectra presented in Figs. 3 and 4, are shown in Figs. 5 and 6.

It should be noted that a strong absorption of this line was observed at $t_{\text{dip}} = 0$, i.e. when the plasma column had the most dense structure. Apart from the $D_\alpha$ line also distinct lines of CII ions were seen, especially near $t_{\text{dip}} = 0$.

Fig. 4. Temporal changes of the optical spectra for DPF-1000U shots performed at $p_\text{g} = 2.4$ mbar and $U_\text{o} = 23$ kV, with the gas-puffing at various instants: 1.5 ms (left) and 2.0 ms (right) before the application of the high-voltage pulse.

Fig. 5. Profiles of the $D_\alpha$ line measured at $p_\text{g} = 1.6$ mbar, $U_\text{o} = 23$ kV and different instants after the current dip, as recorded for DPF-1000U shots with the gas-puffing performed 1.5 ms (left) and 2.0 ms (right) before the discharge was triggered.
Analysis of experimental results

In order to determine the plasma density in DPF-1000U discharges without gas-puffing the recorded Dα lines were fitted by a Lorentzian profile. An example is presented in Fig. 7. Analogous fitting was performed also for the Dα line recorded during DPF-1000U discharges carried out with the gas-puffing. On the basis of those fits and taking into account the full width at the half maximum (FWHM) it was possible to estimate the corresponding plasma electron density values $n_e$. The use was made of the known formula [7]:

$$\Delta \lambda_{1/2} = 2.5 \times 10^{-9} \alpha_{1/2} \cdot (n_e)^{2/3}$$

where $\Delta \lambda_{1/2}$ is a Stark full width at the half maximum of the analyzed spectral line, and $\alpha_{1/2}$ is a fractional semi-half-width parameter taken from literature [8, 9], which depends on the plasma temperature.

On the basis of the above formula and the FWHM values measured for the investigated Dα lines, which were recorded at different moments during the discharges without and with the gas-puffing, it was possible to perform corresponding computations. They were carried out for the investigated DPF-1000U discharges, under an additional assumption that the plasma temperature range was similar to that determined in earlier experiments [10, 11], and their results are presented in Fig. 8.

It should here be noted that the estimates of the averaged plasma density for discharges without gas-puffing presented here do not differ considerably from results of earlier interferometric measurements of freely propagating plasma streams in the PF-1000 facility (i.e. without any target) [4].

From the diagrams presented in Fig. 8 it can also be seen that in the first phase of the DPF-1000U pinch column decay (until about 1.5 $\mu$s), application of the gas-puffing resulted in a higher electron density of the generated plasma streams, which in most cases reached values as high as $6 \times 10^{18}$ cm$^{-3}$. In the later phase of the pinch column decay the observed changes in electron densities were not so strong and the estimated values amounted to about $(1-2) \times 10^{18}$ cm$^{-3}$.

It should be noted that the density values obtained for deuterium discharges under the initial pressure of $p_o = 2.4$ mbar were noticeably higher than those recorded at $p_o = 1.6$ mbar. One should also note that these estimates refer to plasma density values on the z-axis of the pinch column, at a distance of 9 cm from the electrode outlets. The obtained values were of course averaged along the optical observation axis.

Summary and conclusions

The most important results of the reported study can be summarized as follows: the measurements performed by means of the optical emission spec-
Decay showed that for the DPF-1000U discharges performed with the gas-puffing the electron density in the pinch column (during the first instants of its decay) was considerably higher (about $6 \times 10^{18}$ cm$^{-3}$) compared to values measured for discharges without gas-puffing (about $(1-2) \times 10^{18}$ cm$^{-3}$).

Such a difference was particularly evident in earlier phases of the pinch decay after the current peculiarity. In later phases of the pinch decay the electron densities were comparable in both cases, i.e. with and without the gas-puffing, and their values amounted to about $(1-2) \times 10^{18}$ cm$^{-3}$. It should be noted that estimates of the plasma electron density were performed on the basis of the D$_{\alpha}$ line profiles, because the D$_{\beta}$ line showed complex shapes, probably due to closely lying impurity lines (of Cu- and Fe-species). Error bars were not marked in diagrams presented in Fig. 8, but under the assumption about the temperature range (see above) they were estimated to amount to about 30–50% of the given values. Nevertheless, the measurements performed proved valuable for the determination of the discharge characteristics.

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Fig. 8. Temporal changes of the plasma electron density on the z-axis at a distance of 9 cm from the electrode outlets, as determined for the DPF-1000U discharges performed without and with the gas-puffing.

References


